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Docket No.: S8810.0003/P003
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Masashi Kawasaki et al.

Application No.: 10/588,283

Confirmation No. N/A

Filed: August 4, 2006

Art Unit: Not Yet Assigned

For: METHOD OF MANUFACTURING THIN
FILM, METHOD OF MANUFACTURING p-
TYPE ZINC OXIDE THIN FILM AND
SEMICONDUCTOR DEVICE

Examiner: Not Yet Assigned

NOTICE OF ENTITLEMENT TO SMALL ENTITY STATUS

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

The undersigned has learned that the assignee of this application, Tohoku University is a non-profit organization and therefore entitled to small entity status.

It is requested that all pertinent U.S. Patent and Trademark Office records relating to the subject application be changed to reflect this correction.

Dated: December 7, 2006

Respectfully submitted,

By 

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